



03500.0150001 (35.C13584 Div. 1)

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)
MASAKI MIZUTANI, ET AL.)
U.S. Appln. No.: 09/813,137)
Filed: March 21, 2001)
For: METHOD OF PRODUCING)
SEMICONDUCTOR THIN FILM AND)
METHOD OF PRODUCING SOLAR)
CELL USING SAME)
Examiner: John L. Goff II
Group Art Unit: 1733
June 8, 2004

Mail Stop Issue Fee
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

SUBMISSION OF SUPPLEMENTAL
APPLICATION DATA SHEET

Sir:

In the Declaration filed with the subject application, the filing date of one of the foreign priority applications is listed incorrectly. In particular, the filing date for Japan 11-159374 reads "7 June 1998" but should read --7 June 1999--. However, Applicants note that the correct filing date appears on the official Filing Receipt.

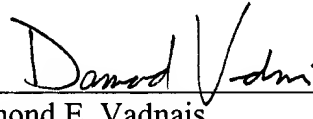
Applicants wish to thank the Examiner for the courtesies extended to Applicants' undersigned representative during a telephonic interview conducted on May 18, 2004. During the interview, it was agreed that it would not be necessary to submit a Substitute Declaration to attend to the error in the Declaration, as was required by the Notice of Allowability mailed May 5, 2004. The Examiner indicated that submission of a Supplemental

Application Data sheet would be sufficient. See Interview Summary mailed May 27, 2004.

Accordingly, submitted herewith is a Supplemental Application Data Sheet listing the correct foreign priority information.

Applicants' undersigned attorney may be reached in our Washington, D.C. office by telephone at (202) 530-1010. All correspondence should continue to be directed to our below-listed address.

Respectfully submitted,

A handwritten signature in dark ink, appearing to read "Damond Vadnais", is written over a horizontal line.

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Supplemental Application Data Sheet for U.S. Patent Application No. 09/813,137

Foreign Priority Information

Country::	Application Number::	Filing Date::	Priority Claimed::
JAPAN	10-171403	06/18/1998	Yes
JAPAN	11-159374	06/07/1999	Yes